

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kenichi Yokouchi et al.

Serial No.: 10/645,065

Filed: August 21, 2003

Confirmation No.: 6981

Date: December 26, 2006

Group Art Unit: 1763

Examiner: Sylvia Macarthur

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING  
METHOD

---

**VIA EFS-WEB**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**SUBMISSION**

Sir:

Submitted herewith are copies of search reports issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

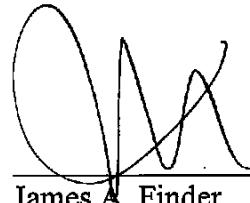
I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

Credit card payment for the required filing fee of \$180.00 is being submitted via EFS-WEB.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE PATENT AND  
TRADEMARK OFFICE EFS FILING  
SYSTEM ON December 26, 2006.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'James A. Finder', is written over a horizontal line.

James A. Finder  
Registration No.: 30,173  
OSTROLENK, FABER, GERB & SOFFEN, LLP  
1180 Avenue of the Americas  
New York, New York 10036-8403  
Telephone: (212) 382-0700

JAF:lf  
Enclosures

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application 10/645,065		OFGS File No. P/2699-30			
		Applicant Kenichi YOKOUCHI et al.					
		Filing Date August 21, 2003		Group Art Unit 1763			
<b>U.S. PATENT DOCUMENTS</b> (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate	
	US-6,435,200	08-2002	Langen				
	US-2002/0148489	10-2002	Langen				
	US-2004/0020427	02-2004	Langen				
	US-2006/0144429	07-2006	Langen				
	US-2002/0050244	05-2002	Engesser				
	US-2005/0026448	02-2005	Engesser				
	US-						
<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation	
						Yes	No
	2000-343054	12-2000	Japan			corresponds to all U.S. Patent documents listed above for Langen	
	7-122529	05-1995	Japan			X	
	2003-37097	02-2003	Japan			X	
	2002-246364	08-2002	Japan			corresponds to all U.S. Patent documents listed above for Engesser	
	2002-75953	03-2002	Japan			X	
	2002-75956	03-2002	Japan			X	
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Office Action dated November 14, 2006 issued for Japanese Patent Application No. 2002-240891					
		Office Action dated November 14, 2006 issued for Japanese Patent Application No. 2002-283458					
Examiner		Date Considered					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							